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#### **Contents**

### OPTICAL MANUFACTURING I 11487 03 Fabrication of a 500 mm extreme freeform conformal window [11487-2] 11487 04 Observation of pressure distribution between tool and surface in different polishing situations [11487-3] 11487 05 The results of Goodman Technologies NASA Phase II SBIRs for additive manufacturing of mirrors and telescopes [11487-4] 11487 07 Octopus: a simple and effective tool for polishing slurry monitoring [11487-6] **OPTICAL TESTING AND MODELING** 11487 09 Error sources, compensation, and probe path optimization for on-machine metrology of freeform optics [11487-7] 11487 0A Isotropic grating coupler for 3D silicon photonic architectures [11487-8] 11487 OB A method for reconstructing the equation of the aspherical surface of mirrors in an explicit form using a device with a wavefront sensor [11487-9] 11487 0D The optical system development and alignment for the Korsch type telescope [11487-11] 11487 OE Implementation of a laser-truss based telescope metrology system at the Large Binocular **Telescope** [11487-58] **OPTICAL TESTING / INTERFEROMETRY** 11487 OI Interferometric measurement with robot kinematics [11487-15] 11487 OJ Solutions for environmentally robust interferometric optical testing [11487-16] **OPTICAL TESTING / DEFLECTOMETRY** 11487 OK Aberration-induced errors in deflectometric measurement [11487-17]

11487 OL	Non-planar illumination sources for deflectometry [11487-18]
11487 OM	In-process metrology for segmented optics UV curing control [11487-19]
11487 ON	Full-aperture optical metrology for inflatable membrane mirrors [11487-20]
11487 00	Computational alignment of on-machine deflectometry [11487-57]
	OPTICAL SYSTEM AND ALIGNMENT
11487 OT	Predictive Thermal Control (PTC) technology to enable thermally stable telescopes: year three status [11487-25]
11487 OU	Precision cementing of doublets without using a rotary table [11487-26]
11487 OV	Alignment of Multi-Order Diffractive Engineered (MODE) lens segments using the Kinematically-Engaged Yoke System [11487-27]
11487 OW	Hyperion: Far-UV cross dispersion spectroscope design [11487-28]
11487 OX	Precision space freeform optics for Microcarb: final report [11487-29]
11487 OY	A catalog approach to mounting optics for space applications [11487-56]
	POLYMER OPTICS AND MOLDED GLASS OPTICS I
11487 OZ	Precision glass molding of infrared optics with anti-reflective microstructures [11487-30]
11487 10	Process evaluation and optimization for freeform precision glass molding [11487-31]
	POLYMER OPTICS AND MOLDED GLASS OPTICS II
11487 15	Distinguishing characteristics of diffractive optical elements and Fresnel lenses [11487-36]
11487 16	Foundry produced SU-8 inverted-rib waveguide-based components [11487-37]
	OPTICAL MANUFACTURING II
11487 18	Fabrication and characterization of diffracto-freeform optics [11487-39]

#### **OPTICAL CHARACTERIZATION**

	OF HOAE CHARACTERIZATION
11487 1F	Absolute characterization of gravity sag [11487-46]
11487 1G	A coronagraph for the sensing of fabrication errors in diffraction gratings [11487-47]
11487 1H	Innovative test method for validating image quality performance of automotive lenses over operating temperature range $[11487\text{-}48]$
·	POSTER SESSION
11487 1L	Hybrid-process-chain for polishing optical glass lenses – HyoptO [11487-52]
11487 10	Measurement of retardance variations over the apertures of liquid-crystal variable retarders [11487-55]